

Mail Stop: Amendment  
PATENT  
8007-1114

**IN THE U.S. PATENT AND TRADEMARK OFFICE**

In re application of

Hiroki SATO et al.

Conf. 6778

Application No. 10/588,187

Group 1621

Filed August 2, 2006

Examiner T. Hain

ALKOXIDE COMPOUND, MATERIAL FOR THIN FILM FORMATION,  
AND PROCESS FOR THIN FILM FORMATION

**AMENDMENT**

Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

January 5, 2009

Sir:

In response to the non-final Office Action mailed  
October 5, 2009, please amend the above-identified application  
as follows:

**Amendments to the Claims** are reflected in the  
listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 4 of this paper.

An **Appendix** is attached following the signature page  
of this paper.